## **SPMDL: Software Product Metrics Definition Language**

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Software metrics are becoming more acceptable measures for software quality assessment. However, there is no standard form to represent metric definitions, which would be useful for metrics exchange and customization. In this article, we propose the Software Product Metrics Definition Language (SPMDL). We develop an XML-based description language to define software metrics in a precise and reusable form. Metric definitions in SPMDL are based on meta-models extracted from either source code or design artifacts, such as the Dagstuhl Middle Meta-model, with support for various abstraction levels. The language defines several flexible computation mechanisms, such as extended Object Constraint Language queries and predefined graph operations on the meta-model. SPMDL provides an unambiguous description of the metric definition; it is also easy to use and is extensible.

CCS Concepts:  $\cdot$  Software and its engineering  $\rightarrow$  Software notations and tools; Context specific languages; Domain specific languages;

Additional Key Words and Phrases: Software metrics, definition language

## **ACM Reference format:**

Mohammad Alshayeb, Yasser Shaaban, and Jarallah Al-ghamdi. 2018. SPMDL: Software Product Metrics Definition Language. J. Data and Information Quality 9, 4, Article 20 (April 2018), 30 pages. https://doi.org/10.1145/3185049

This work is supported by King Fahd University of Petroleum and Minerals. This work is done under FT-06/12. Authors' addresses: M. Alshayeb, King Fahd University of Petroleum and Minerals, Dhahran 31261, Saudi Arabia; email: alshayeb@kfupm.edu.sa; Y. Shaaban, Microsoft Corporation, 1301 1st Ave, Seattle, WA 98101; email: yasser.shaaban@live.com; J. Al-Ghamdi, Education Evaluation Commission, Riyadh 11683, Saudi Arabia; email: jalghamdi@eec.gov.sa. Permission to make digital or hard copies of all or part of this work for personal or classroom use is granted without fee provided that copies are not made or distributed for profit or commercial advantage and that copies bear this notice and the full citation on the first page. Copyrights for components of this work owned by others than ACM must be honored. Abstracting with credit is permitted. To copy otherwise, or republish, to post on servers or to redistribute to lists, requires prior specific permission and/or a fee. Request permissions from permissions@acm.org.

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https://doi.org/10.1145/3185049